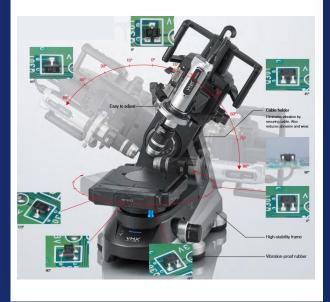
# **Keyence VHX-7000 Optical Microscope**





## Description

The Keyence VHX-7000 is a 4K high-accuracy digital microscope designed for detailed inspection and failure analysis. It features fully-focused imaging capabilities, even at high magnifications, without the need for focus adjustments. The system includes a motorized turret supporting automatic observation from 20x to 6000x magnification, a motorized XYZ stage for precise positioning and focusing, and a high-resolution lens with a maximum numerical aperture (NA) of 0.9. Additionally, it is equipped with a 12-megapixel 4K CMOS image sensor, providing six times the detail at every magnification level.



## **Specifications**

- Seamless zoom from 20x to 6000x using a motorized turret, allowing detailed observations without manual changing lenses
- 3D Profiling: Captures height variations across a surface to analyze roughness.
- Calculates common roughness metrics like R<sub>a</sub> (average roughness), R<sub>z</sub> (maximum height), and R<sub>q</sub> (root mean square roughness).
- Non-Contact Measurement: Unlike traditional stylus-based profilometers, the VHX-7000 performs non-destructively.

### **Further information**

- 3D Imaging & Measurement Captures height information for 3D display and color mapping.
- High-Resolution 4K Imaging Provides ultraclear images for detailed inspections.
- Fully-Focused Imaging Eliminates the need for manual focus adjustments.
- Multi-Angle Observation Allows lens tilting and rotation while keeping the target centered.
- Depth Composition Automatically combines multiple images to create a fully-focused view.
- Automatic Area Measurement Measures surface areas, roughness, and dimensions.
- Non-Destructive Analysis Enables precise inspection without damaging the sample.
- Advanced Lighting Options Adjustable multidirectional illumination for optimal contrast.

#### **Publications**

Always important for images for the supplementary information file, as e.g. in

[1] S. Saleh, S. Daboss, T. Philipp, D. Schaefer, M. Rohnke, C. Kranz, ChemElectroChem 2025, e202400707.





